

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q85096

Masamichi INENAGA, et al.

Appln. No.: 10/516,693

Group Art Unit: 2886

Confirmation No.: 6877

Examiner: Isiaka O. Akanbi

Filed: December 6, 2004

For: WAFER PRE-ALIGNMENT APPARATUS AND METHOD

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on
May 5, 2008:

REMARKS

An Examiner's Interview Summary Record (PTO-413) dated May 5, 2008.

During the interview, the following was discussed :

1. Identification of claims discussed: Claim 1
2. Identification of art discussed: Kiyokawa et al. (5,289,263) and Mimura et al.
(5,880,816)
3. Results of Interview: Claim amendments were discussed. As per the Examiner's
suggestions, claims are amended in the Amendment filed on May 12, 2008.

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It is respectfully submitted that the instant STATEMENT OF SUBSTANCE OF INTERVIEW complies with the requirements of 37 C.F.R. §§1.2 and 1.133 and MPEP §713.04.

It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,

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Date: June 16, 2008